



AF/IFW
Attorney's Docket No.: 10559-584002
Intel Ref.: P12765C

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Chris E. Barns et al.
Serial No. : 10/799,996
Filed : March 12, 2004
Title : POLYSILICON OPENING POLISH

Art Unit : 1765
Examiner : Lan Vinh

Ok to enter

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

LV
8/19/06

AMENDMENT IN REPLY TO ACTION OF APRIL 17, 2006

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 17, 2006
Date of Deposit
Meredith A. Finch
Signature

Meredith A. Finch
Typed or Printed Name of Person Signing Certificate